

Notice of References Cited	Application/Control No. 10/809,929	Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.	
	Examiner David S. Kim	Art Unit 2613	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0035168 A1	02-2003	Qian et al.	359/124
*	B	US-6,545,782 B1	04-2003	Wang et al.	398/79
	C	US-			
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	F	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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